

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

White, et al.

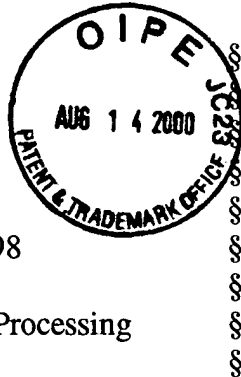
Serial No.: 09/082,483

Filed: May 20, 1998

For: Modular Substrate Processing
System

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:



Group Art Unit: 2824

Examiner: Luu, P.

CERTIFICATE OF MAILING	
37 C.F.R. 1.8	
I hereby certify that this correspondence is being deposited on August 11, 2000, with the U. S. Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.	
Date	Signature
11 August 2000	William B. Patten

RESPONSE TO OFFICE ACTION DATED APRIL 11, 2000

In response to the Office Action dated April 11, 2000 having a shortened statutory period for response extended one month to expire on August 11, 2000, please enter the following amendments and reconsider the claims pending in the application for reasons discussed below. Please charge the fee of \$1752.00 for 28 additional total claims and 16 additional independent claims to Deposit Account No. 20-0782/AMAT/2253.P1/AKT/WBP.

IN THE CLAIMS:

Please amend the claims as follows:

1. (Twice amended) An apparatus for performing a process on a substrate, comprising:
a conveyor to support the substrate along a flow path;
a substrate transfer mechanism configured and arranged to remove the substrate from
and place another substrate on said conveyor; and
at least one processing island located adjacent to said flow path, said processing island
comprising a load lock chamber and a processing chamber and having a valve for introduction
and extraction of the substrate into and out of an interior thereof.